# New perspectives on thin film technology for SRF

Enzo Palmieri

Legnaro National Laboratories ISTITUTO NAZIONALE DI FISICA NUCLEARE & Padua University

FFC Kick-off Meeting, CERN, Geneva, Dec 8-10, 2014

#### Toward low cost substrates

## **Seamless** Cavity Cold Forming









# SRF requires a large Statistics



## New perspectives on thin films

# when working on the **Niobium-Copper Interface**

### **Nb Sputtering** into Cu Cavities



#### **RF** losses

#### depend also on the status of the

### cavity external surface







#### **Any SRF improvement**

must pass for a deeper comprehension of the heat flux transport mechanism to

Liq-He



abia natio@iel.infn.it - palmiari@iel.infn.it